

Low Pulsation Realized Without Damper  
Contributes to Total Cost Reduction



Patent

JAPAN / CHINA / KOREA / TAIWAN

The Heart of Industry



FLP-75W  
EFG-32M



FLP-60W  
EFG-20M

## Low Pulsation Realized Without Damper Contributes to Total Cost Reduction

The unique design of the FLP bellows pump achieves low pulsation and high pressure sustaining capability. This produces a stable discharge capacity and pressure without the use of a dampener. Reduced air consumption up to 30% compared to our previous models is also achieved.



### Low Pulsation

The unique drive mechanism of the system determines and maintains optimum movement of the bellows and supply-air switching to give minimum discharge pulsation. (PAT.)



### Reduction of Air Consumption

Reduced air consumption up to 30% compared to our previous models is achieved with no reduction of pump performance.



### High Sustained Pressure Capability

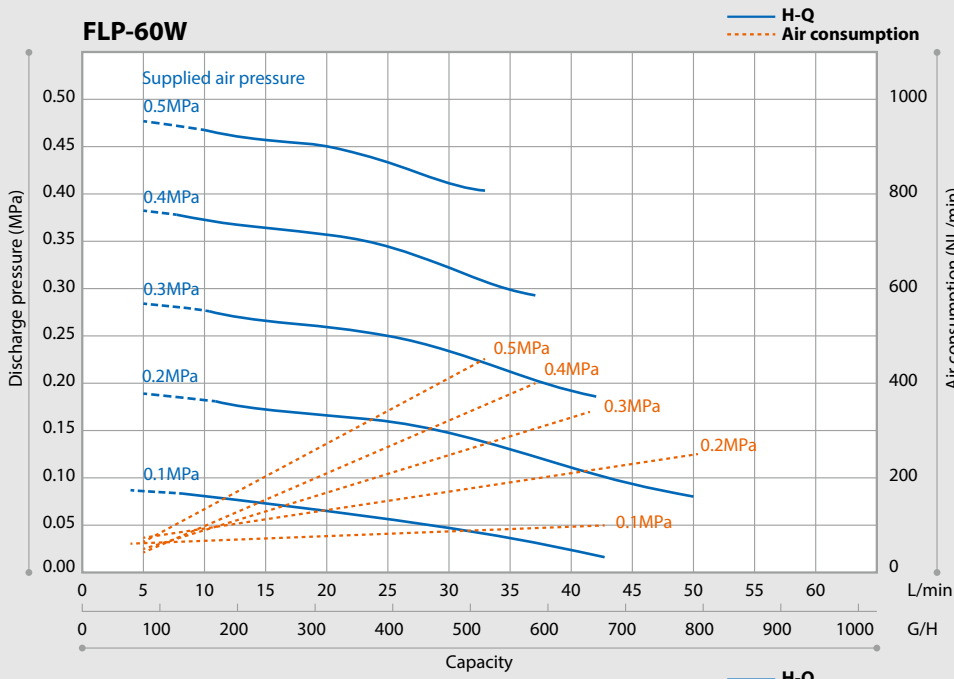
The optimum bellows movement improves pressure sustaining capability to maintain stable discharge capacity and pressure under frequent load change, especially in single wafer processing.



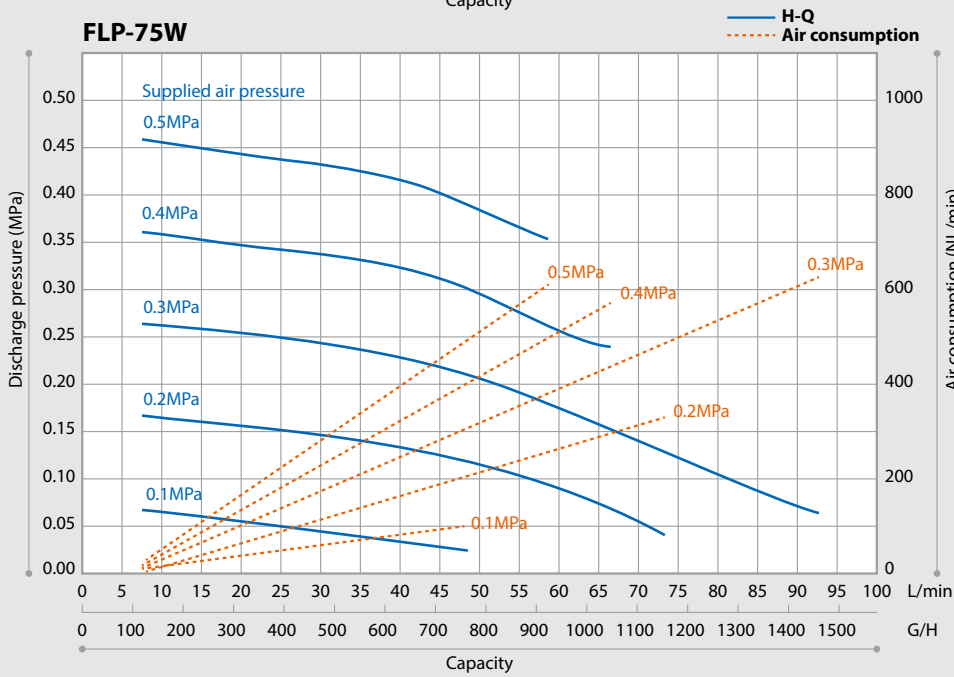
### Elimination of a Damper

The pump works without the use of a dampener, saving space inside equipment & installation costs such as fluoroplastic joints. The total weight/size of the equipment is also minimized.

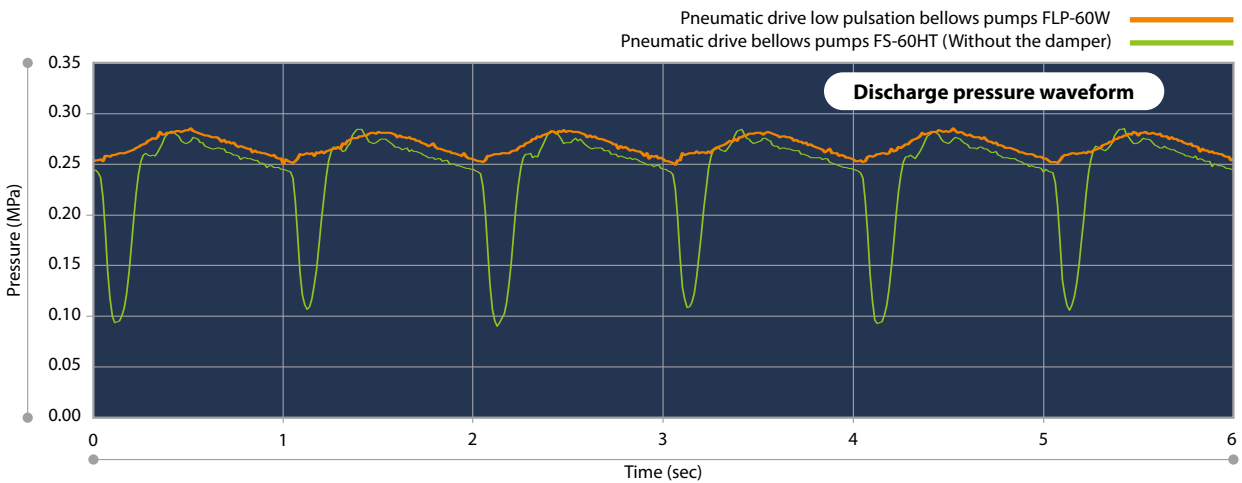
**FLP-60W**



**FLP-75W**



**Compared to Existing Pumps**



Sharp drops of discharge pressure are minimized, reducing the pulsation compared to existing pumps, Suction pressure drops are at the same level as existing pumps, but the pulsation width has been reduced.

